

**RECEIVED  
CENTRAL FAX CENTER  
JAN 28 2005**

Docket No. EHAR0010  
US App. No. 09/856,402

---

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of : TERUYUKI NAKANO et al.

Application No. : 09/856,402

Filed : October, 12, 2001

For : POLISHING MACHINE FOR PERIPHERAL  
EDGE OF SEMICONDUCTOR

Examiner : MACARTHUR, SYLVIA

Attorney Docket No. : EHAR0010

---

**PRELIMINARY AMENDMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

In response to the Office Action dated November 4, 2004 and in view of the telephone interview of January 21, 2005, Applicant submits herewith the following amendments and remarks together with a Request for Continued Examination (RCE) .